

Docket No.: 21806-00157-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Robert T. Froebel et al.

Application No.: 10/707,864

Confirmation No.: 1863

Filed: January 19, 2004

Art Unit: 2877

For: ALIGNMENT MARK SYSTEM AND
METHOD TO IMPROVE WAFER
ALIGNMENT SEARCH RANGE

Examiner: I. O. Akanbi

RESPONSE TO NON-COMPLIANT AMENDMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated June 30, 2006, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.